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TRANSMITTAL		Filing	Date	January 13, 2004		
FORM			lamed Inventor	Xie,	Xie, Jun	
to be used for all correspondence a	fter initial filing)	Art Un	it	Not	Yet Assigned	
		Exami	ner Name	Not	Yet Assigned	
Total Number of Pages in This Submission	6	Attorn	ey Docket Number	020	859-002510US	
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Fee Attached	Licens	ing-relate	ed Papers		Appeal Communication and Interferences	to Board of Appeals
Amendment/Reply	Petitio	n			Appeal Communication Notice, Brief, Reply Brief,	to Group (Appeal
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Affidavits/declaration(s)			ey, Revocation espondence Address		Status Letter	
Extension of Time Request		inal Disclaimer			Other Enclosure(s) (please identify below):	
Express Abandonment Request		est for Refund Number of CD(s)		1	eturn Postcard; and	
☐ Information Disclosure Statement (2 pgs) w/attached PTO/SB/08A (1 pg), and PTO/SB/08B (1 pg) (citing refs 1-27) ☐ Certified Copy of Priority			The Commissioner is		copy of each of 27 refe	
Document(s)	Rema	ırks	Account 20-1430.		,	•
Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53 * Note: R			ces not included in t	the tot	al number of pages	above.
	SIGNATURE O	F APPL	ICANT, ATTORNEY	OR A	GENT	
Firm Townsend a	nd Townsend a					-
or Individual Kent J. Tobin Reg. No. 39,496						
Signature						
Date 4/21/04						
CERTIFICATE OF TRANSMISSION/MAILING						
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.						
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Attorney Docket No.: 020859-002510US

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APR 2 6 2004

TOWNSEND and TOWNSEND and CREW LLP

By: Edward Masmas

Edward Masinas

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Jun Xie et al.

Application No.: 10/757,973

Filed: January 13, 2004

For: INTEGRATED ELECTROSTATIC PERISTALTIC PUMP METHOD AND

APPARATUS

Examiner: Not Yet Assigned

Art Unit: Not Yet Assigned

INFORMATION DISCLOSURE

STATEMENT UNDER 37 CFR §1.97 and

§1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Jun Xie et al.

Application No.: 10/757,973

Page 2

Applicant believes that <u>no fee is required</u> for submission of this statement.

However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

Kent J. Tobin Reg. No. 39,496

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Tel: 650-326-2400 Fax: 650-326-2422

KJT:rms 60186224 v1



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet of 2

	Complete if Known
Application Number	10/757,973
Filing Date	January 13, 2004
First Named Inventor	Xie, Jun
Art Unit	Unassigned
Examiner Name	Unassigned
Attorney Docket Number	020859-002510US

U.S. PATENT DOCUMENTS+							
Examiner Initials*	Cite No.1	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	1	US 5,836,750	11-17-1998	Cabuz	т ідагоз Арреат		
	2	US 6,033,191	03-07-2000	Kamper et al.			
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	8	US 6,206,022 B1	03-27-2001	Tsai et al.			
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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document		Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant		
		Country Code ³	Number ⁴	Kind Code ⁸ (if known)	MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	T ⁶
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Examiner Signature	Date Considered	

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Substitute for form 1449B/PTO Complete if Known Application Number 10/757,973 **INFORMATION DISCLOSURE** Filing Date January 13, 2004 STATEMENT BY APPLICANT First Named Inventor Xie, Jun Art Unit Unassigned (use as many sheets as necessary) Examiner Name Unassigned Sheet Attorney Docket Number 020859-002510US

		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item	$\overline{}$
Examiner Initials *	Cite No. ¹	(book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т
	16	DEGANI et al., On the Effect of Residual Charges on the Pull-in Parameters of Electrostatic Actuators, Sensors and Actuators A 97-98 (2002), pp 563-568.	
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Examiner	Date	
Signature	Considered	

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